

Notice of References Cited

Application/Control No.

09/744,793

Applicant(s)/Patent Under
Reexamination
MANSOUR ET AL.

Examiner

Yelena G. Gakh, Ph.D.

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	L	US-			
	M	US-			

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Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.